



LHC Injectors Upgrade

Introductory remarks: LIU baseline and beam parameters through the chain

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Acknowledgments: LIU-PT members and deputies, H. Bartosik

Outline:

- LIU baseline
- Proton beam parameters
- Pb ion beam parameters



LIU baseline as of 1/1/16

(Compact → details in the talks during LIU session)

- **PSB**

- New H⁻ charge exchange injection at 160 MeV from Linac4 to double brightness
- Acceleration to 2 GeV with replacement of C02-C04-C16 RF systems by Finemet cavity based RF system, and new main power supply

- **Linac3 + LEIR**

- 100 ms injection rate into LEIR to allow larger accumulated ion current

- **PS**

- New injection at 2 GeV for protons to mitigate space charge
- Newly installed and upgraded longitudinal feedbacks (impedance reduction and against CBI)

- **SPS**

- Power upgrade of the main 200 MHz RF system, double available 800 MHz voltage, new LL RF system including slip stacking capability
- Electron cloud mitigation through beam induced scrubbing + a-C coating of QFs and one arc – keep option of full a-C coating staged to LS3, if proved necessary by Run 3 operation
- New beam dump system in LSS5 and new design of protection devices to comply with the target HL-LHC beam parameter values
- Longitudinal impedance reduction through QF-type flange shielding and improvement of HOM damping in 200 MHz cavities





LIU baseline as of 1/1/16

(Compact → details in the talks during LIU session)

- **PSB** → Talk by **K. Hanke**
 - New H⁻ charge exchange injection at 160 MeV from Linac4 to double brightness
 - Acceleration to 2 GeV with replacement of C02-C04-C16 RF systems by Finemet cavity based RF system, and new main power supply
- **Linac3 + LEIR** → Talk by **R. Scrivens**
 - 100 ms injection rate into LEIR to allow larger accumulated ion current
- **PS** → Talk by **K. Hanke**
 - New injection at 2 GeV for protons to mitigate space charge
 - Newly installed and upgraded longitudinal feedbacks (impedance reduction and against CBI)
- **SPS** → Talk by **B. Goddard**
 - Power upgrade of the main 200 MHz RF system, double available 800 MHz voltage, new LL RF system including slip stacking capability
 - Electron cloud mitigation through beam induced scrubbing + a-C coating of QFs and one arc – keep option of full a-C coating staged to LS3, if proved necessary by Run 3 operation
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General

→ RF talk by **H. Damerou**

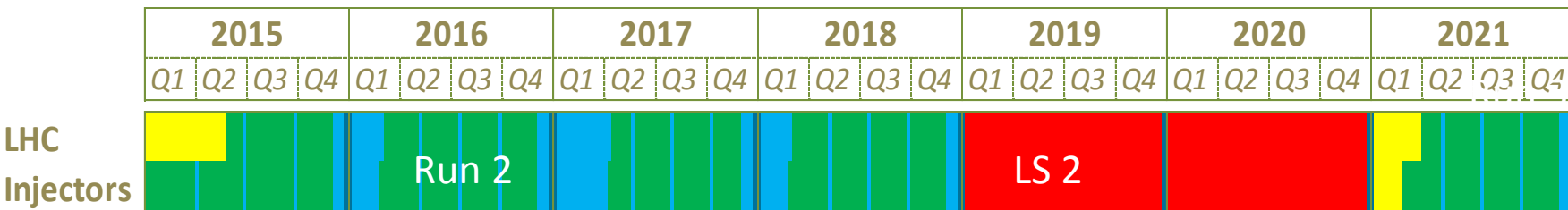
→ Transverse feedback talk by **W. Höfle**



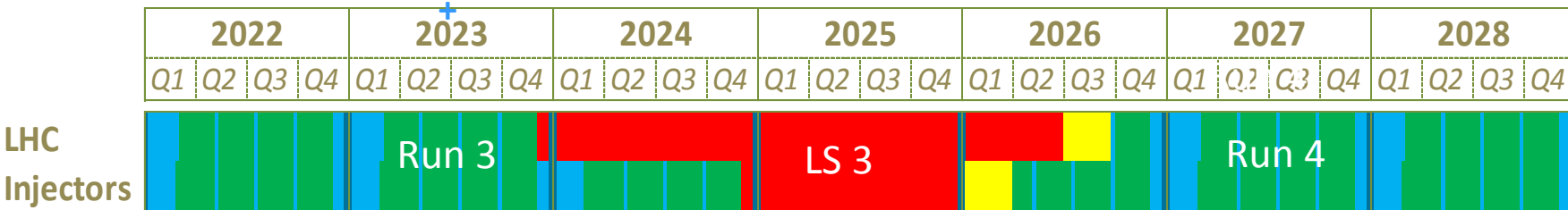


Timelines of LIU

- **Activities until LS2**
 - Beam and simulation studies (e.g. space charge, electron cloud, impedance) to validate beam performance
 - Design, procurement and test of equipment (e.g. protection devices)
 - Installation/cabling work during (E)YETS's when possible
 - Civil engineering work on surface (e.g. new MPS building for PSB)
- **Main LIU installations and hardware work during LS2**
- **Beam commissioning of LIU beams after LS2**
 - **Ion beams** to be ready by **end 2021**
 - **Proton beams** during **Run 3** to be ready for LHC physics after **LS3**



PHASE 1 with LIU studies, equipment design&test, installation



beam commissioning

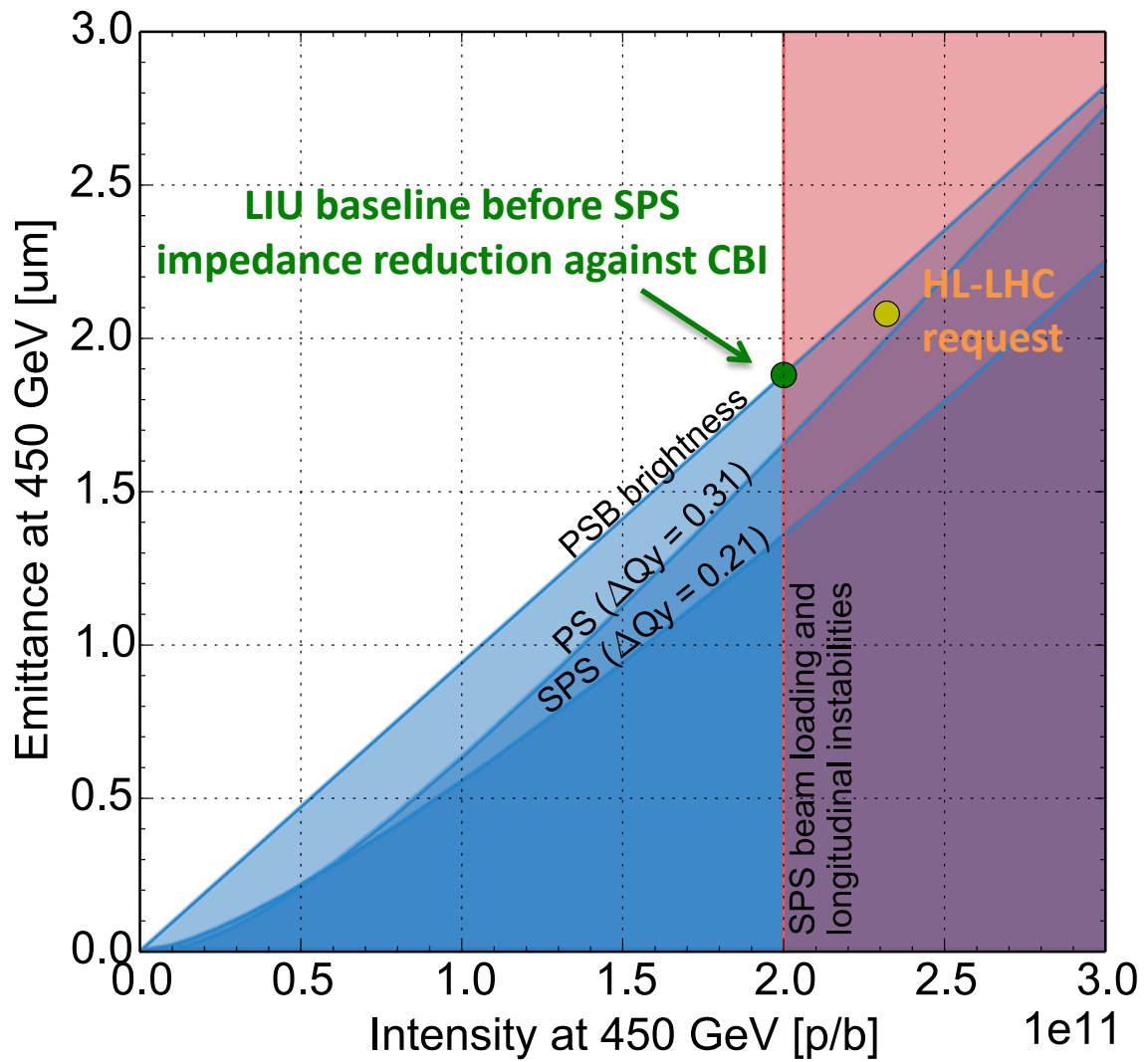
HL-LHC installation

PHASE 2





LIU performance reach for protons (25 ns)

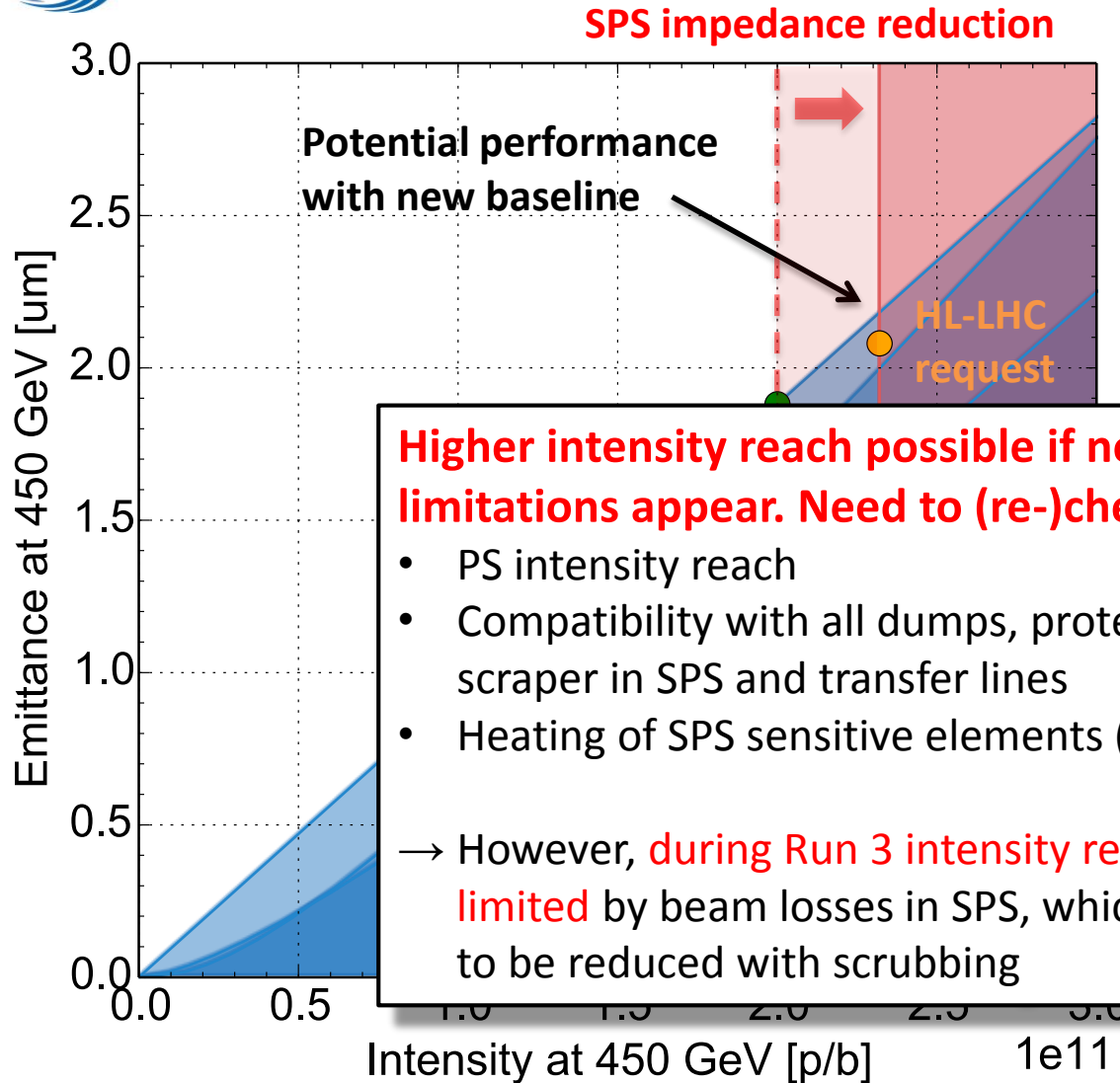


	\mathcal{N} ($\times 10^{11}$ p/b)	ϵ (μm)
LIU Baseline	2.0	1.9
LIU BCMS	2.0	1.4
HL-LHC	2.3	2.1





LIU performance reach for protons (25 ns)



- **Baseline as of 1/1/2016**
 - Linac4
 - 2GeV PS injection energy
 - 200 MHz SPS RF upgrade
 - SPS impedance reduction (LS2)
 - Partial SPS aC coating (LS2) + scrubbing (Run3)

Higher intensity reach possible if no other limitations appear. Need to (re-)check:

- PS intensity reach
- Compatibility with all dumps, protection devices, scraper in SPS and transfer lines
- Heating of SPS sensitive elements (e.g. kickers)

→ However, **during Run 3 intensity reach could be limited** by beam losses in SPS, which are expected to be reduced with scrubbing

+/-
 maintaining aC coating
 scrubbing not sufficient
 get parameters

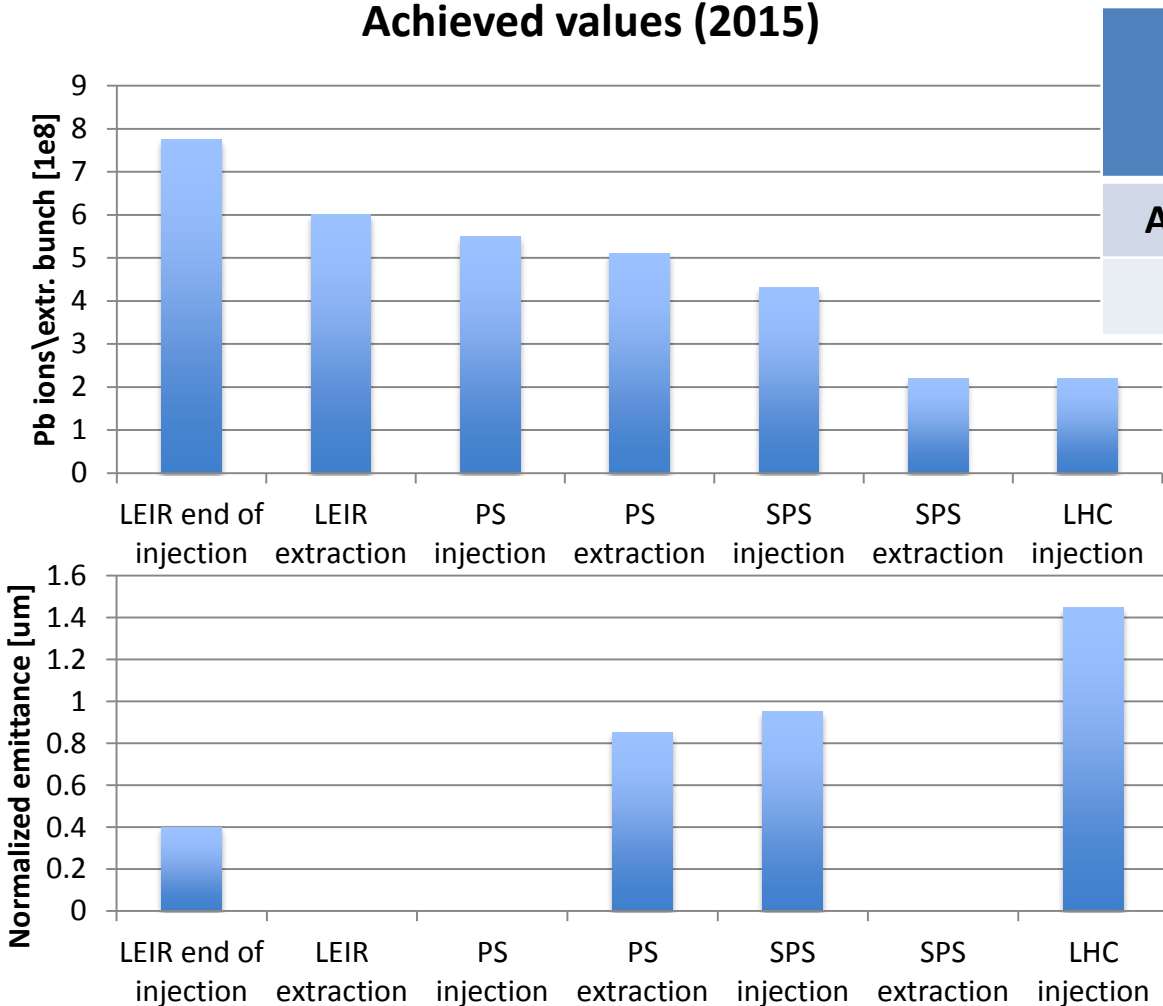




LIU performance reach for Pb ions (50 ns)

- Intensive study program at the end of 2015 to push injector performance and systematically identify bottlenecks and loss/emittance growth distribution

Achieved values (2015)



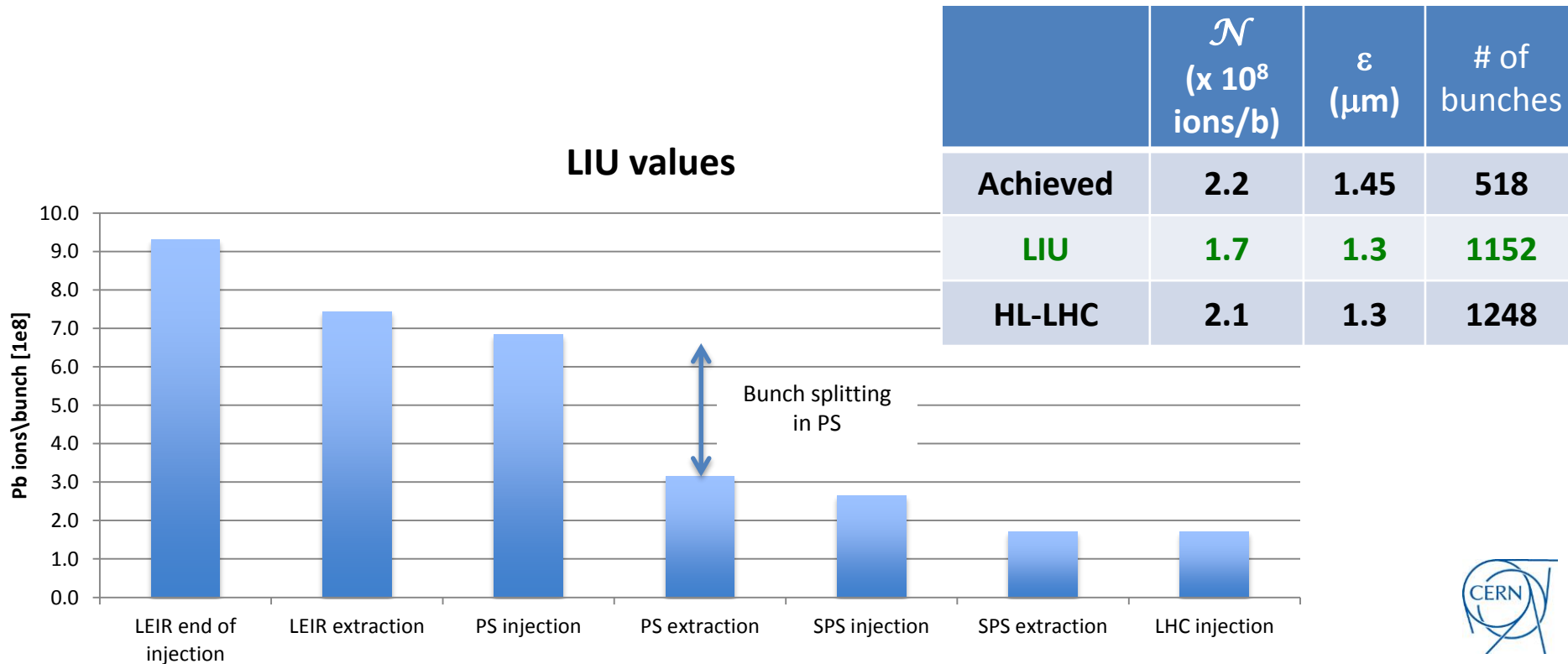
	\mathcal{N} ($\times 10^8$ ions/b)	ε (μm)	# of bunches
Achieved	2.2	1.45	518
HL-LHC	2.1	1.3	1248





LIU performance reach for Pb ions (50 ns)

- Intensive study program at the end of 2015 to push injector performance and systematically identify bottlenecks and loss/emittance growth distribution
- LIU achievable table obtained by combining
 - Extrapolation from information collected in 2015 (transmission, emittance growth)
 - Baseline upgrades, i.e. increase of accumulated intensity in LEIR and slip stacking in SPS





LIU performance reach for Pb ions (50 ns)

- **Intensive study program at the end of 2015 to push injector performance and systematically identify bottlenecks and loss/emittance growth distribution**
- **LIU achievable table obtained by combining**
 - Extrapolation from information collected in 2015
 - Baseline upgrades, i.e. increase of accumulated intensity in LEIR and slip stacking in SPS
- **2016 machine studies with Pb ion beams are crucial to validate predictions, understand losses (in rings and transfers) and explore scenarios**
 - Full functionality of the systems and availability of resources expected
- **Options under consideration/study to push Pb ion beam performance. E.g.**
 - Push the present LHC injection and extraction (MKI/MKD) kicker gaps to (realistic) limits
 - Consider different filling schemes in PS (e.g. with 50 ns spacing resulting in **25 ns in LHC**)
 - 100 ns upgrade of the SPS injection kicker system
 - Reduce LEIR cycling rate

More in the next LIU talks

